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DOCKET NO: 270968US2X PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
SHINSUKE HARADA, ET AL. : ATTN: APPLICATION DIVISION
SERIAL NO: 10/531,582 :
FILED: APRIL 18, 2005 :
FOR: SILICON CARBIDE :
SEMICONDUCTOR DEVICE AND :
ITS MANUFACTURING METHOD :

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 6 of this paper.

Amendments to the Drawings begin on page 15 of this paper and include an attached replacement sheet.

Remarks begin on page 16 of this paper.